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PATENT APPLICATION
I.D.S
2878

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ken OZAWA

Application No.: 09/711,944

Filed: November 15, 2000

Docket No.: 107878

For: METHOD AND APPARATUS FOR PROJECTION EXPOSURE AND DEVICE MANUFACTURING METHOD

OIPE JC147 JUN 13 2001 PATENT & TRADEMARK OFFICE

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INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.

Respectfully submitted,

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